	Application No.	Applicant(s)
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Notice of Allowability	10/043,468 Examiner	FARNWORTH, WARREN M. Art Unit
	Khiem D Nguyen	2823
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
 This communication is responsive to <u>12/08/2003</u>. The allowed claim(s) is/are <u>1-30</u>. 		
3. The drawings filed on 10 January 2002 are accepted by the Examiner.		
4. ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) ☐ All b) ☐ Some* c) ☐ None of the:		
1. Certified copies of the priority documents have been received.		
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received: 5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).		
(a) The translation of the foreign language provisional application has been received.		
6. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE		
7. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
 8. CORRECTED DRAWINGS must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No 		
(b) including changes required by the proposed drawing correction filed, which has been approved by the Examiner.		
(c) I including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No		
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet.		
9. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
Attachm nt(s)		
1 □ Notice of References Cited (PTO-892) 3 ☑ Notice of Draftperson's Patent Drawing Review (PTO-948) 5 □ Information Disclosure Statements (PTO-1449), Paper No 7 □ Examiner's Comment Regarding Requirement for Deposit of Biological Material	4∏ Intervie 6∏ Examin	of Informal Patent Application (PTO-152) w Summary (PTO-413), Paper No er's Amendment/Comment er's Statement of Reasons for Allowance

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DETAILED ACTION

Terminal Disclaimer

The terminal disclaimer filed on 12/08/2003 disclaiming the terminal portion of any patent granted on this application which would extend beyond the expiration date of the full statutory term defined in 35 U.S.C. 154 to 156 and 173, as presently shortened by any terminal disclaimer, of prior Patent No. 5,933,713 and Patent No. 6,204,095 has been reviewed and is accepted. The terminal disclaimer has been recorded.

Allowable Subject Matter

Claims 1-30 are allowed...

Reasons For Allowance

The following is a statement of reasons for the indication of allowable subject matter: The prior art taken alone or in combination neither discloses nor makes obvious the instant process of claims as a whole. Specifically, the prior art of record, Akagawa (U.S. Patent 5,677,576) discloses a method for forming a semiconductor wafer (FIG. 1: 32) having an active surface, the active surface having bond pads (FIG. 1: 36) thereon, the method comprising: forming conductive traces (FIG. 1: 40) over the active surface, each of the conductive traces having a first end, a second end, a top surface, and a bottom surface wherein the bottom surface of the first end of each conductive trace being in contact with at least one of the bond pads (col. 3, lines 10-39), forming a conductive bump (FIG. 1: 46) on the top surface at the second end of the conductive traces wherein the conductive bump having a top portion transverse to the top surface of the conductive traces (col. 3, lines 58-60, and forming a layer of encapsulation material (FIG. 1: 42) to

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cover the active surface of the semiconductor wafer and to surround the conductive bump (col. 3, lines 47-48) but fails to teach or suggest the Applicant's steps of planarizing the top portion of the conductive bump, forming a layer of encapsulation material to cover the active surface of the semiconductor wafer and to surround the planarized conductive bump, and reforming the conductive bump to a preplanarized shape extending above the layer and away from at least portion of the encapsulation material adjacent to the conductive bump as recited in the amended independent claims.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Khiem D Nguyen whose telephone number is (703) 306-0210. The examiner can normally be reached on Monday-Friday (8:00 AM - 5:00 PM).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on (703) 306-2794. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 305-3432 for regular communications and (703) 305-3432 for After Final communications.

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Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

K.N.

December 22, 2003

W. David Coleman Primary Examiner